



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 17, 2026	
IGI Report Number	LG828649104
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	13.46 X 9.57 X 6.01 MM

GRADING RESULTS

Carat Weight	5.01 CARATS
Color Grade	F
Clarity Grade	VVS 2

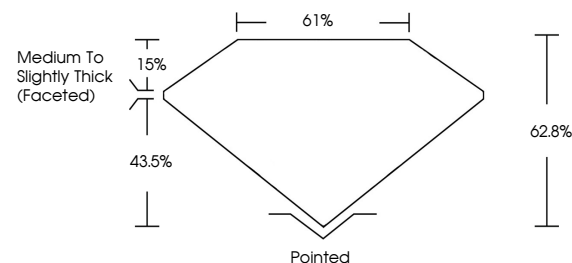
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG828649104

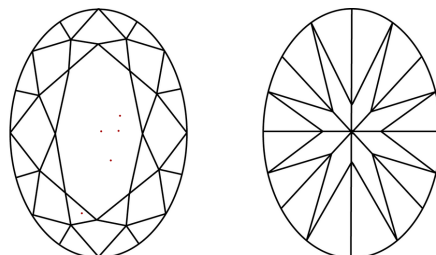
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG828649104
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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August 17, 2026	GL Report No. LG82649104	5.01 CARATS
GI VIAL BRILLANT		F
13.46 X 9.57 X 6.01 MM		VVS 2
		62.5%
		61%
		Medium to Slightly Thick Faceted
		Pointed
		EXCELLENT
		EXCELLENT
		NONE
		ISS: LG82649104

Comments: Very Heavy Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA